

Mohammad Younis

List of Publications by Year in descending order

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201
papers

5,803
citations

101384

36
h-index

88477

70
g-index

205
all docs

205
docs citations

205
times ranked

2054
citing authors

#	ARTICLE	IF	CITATIONS
1	A reduced-order model for electrically actuated microbeam-based MEMS. <i>Journal of Microelectromechanical Systems</i> , 2003, 12, 672-680.	1.7	506
2	MEMS Linear and Nonlinear Statics and Dynamics. <i>Microsystems</i> , 2011, , .	0.3	450
3	Dynamic pull-in phenomenon in MEMS resonators. <i>Nonlinear Dynamics</i> , 2007, 48, 153-163.	2.7	392
4	Reduced-Order Models for MEMS Applications. <i>Nonlinear Dynamics</i> , 2005, 41, 211-236.	2.7	256
5	Modeling and simulations of thermoelastic damping in microplates. <i>Journal of Micromechanics and Microengineering</i> , 2004, 14, 1711-1717.	1.5	237
6	The dynamic behavior of MEMS arch resonators actuated electrically. <i>International Journal of Non-Linear Mechanics</i> , 2010, 45, 704-713.	1.4	202
7	Dynamics of MEMS resonators under superharmonic and subharmonic excitations. <i>Journal of Micromechanics and Microengineering</i> , 2005, 15, 1840-1847.	1.5	193
8	On the nonlinear resonances and dynamic pull-in of electrostatically actuated resonators. <i>Journal of Micromechanics and Microengineering</i> , 2009, 19, 045013.	1.5	128
9	Nonlinear Dynamics of MEMS Arches Under Harmonic Electrostatic Actuation. <i>Journal of Microelectromechanical Systems</i> , 2010, 19, 647-656.	1.7	115
10	On using the dynamic snap-through motion of MEMS initially curved microbeams for filtering applications. <i>Journal of Sound and Vibration</i> , 2014, 333, 555-568.	2.1	105
11	Nonlinear Dynamics of Electrically Actuated Carbon Nanotube Resonators. <i>Journal of Computational and Nonlinear Dynamics</i> , 2010, 5, .	0.7	104
12	An Experimental and Theoretical Investigation of Dynamic Pull-In in MEMS Resonators Actuated Electrostatically. <i>Journal of Microelectromechanical Systems</i> , 2010, 19, 794-806.	1.7	101
13	Natural frequencies and mode shapes of initially curved carbon nanotube resonators under electric excitation. <i>Journal of Sound and Vibration</i> , 2011, 330, 3182-3195.	2.1	97
14	Linear and nonlinear dynamics of micro and nano-resonators: Review of recent advances. <i>International Journal of Non-Linear Mechanics</i> , 2020, 119, 103328.	1.4	97
15	Chemical Gas Sensors: Recent Developments, Challenges, and the Potential of Machine Learning”A Review. <i>Sensors</i> , 2021, 21, 2877.	2.1	94
16	Mode Coupling and Nonlinear Resonances of MEMS Arch Resonators for Bandpass Filters. <i>Scientific Reports</i> , 2017, 7, 41820.	1.6	88
17	Exploration of New Concepts for Mass Detection in Electrostatically-Actuated Structures Based on Nonlinear Phenomena. <i>Journal of Computational and Nonlinear Dynamics</i> , 2009, 4, .	0.7	82
18	Characterization of the performance of capacitive switches activated by mechanical shock. <i>Journal of Micromechanics and Microengineering</i> , 2007, 17, 1360-1370.	1.5	64

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19	Nonlinear dynamics of an electrically actuated imperfect microbeam resonator: experimental investigation and reduced-order modeling. <i>Journal of Micromechanics and Microengineering</i> , 2013, 23, 075012.	1.5	59
20	Computationally Efficient Approaches to Characterize the Dynamic Response of Microstructures Under Mechanical Shock. <i>Journal of Microelectromechanical Systems</i> , 2007, 16, 628-638.	1.7	57
21	Tunable Resonators for Nonlinear Modal Interactions. <i>Scientific Reports</i> , 2016, 6, 34717.	1.6	52
22	The static and dynamic behavior of MEMS arch resonators near veering and the impact of initial shapes. <i>International Journal of Non-Linear Mechanics</i> , 2017, 95, 277-286.	1.4	50
23	Stabilization of electrostatic MEMS resonators using a delayed feedback controller. <i>Smart Materials and Structures</i> , 2010, 19, 035016.	1.8	46
24	An electrically actuated imperfect microbeam: Dynamical integrity for interpreting and predicting the device response. <i>Meccanica</i> , 2013, 48, 1761-1775.	1.2	46
25	Dynamics of MEMS Arches of Flexible Supports. <i>Journal of Microelectromechanical Systems</i> , 2013, 22, 216-224.	1.7	46
26	Nonlinear-Based MEMS Sensors and Active Switches for Gas Detection. <i>Sensors</i> , 2016, 16, 758.	2.1	46
27	AN IMPERFECT MICROBEAM UNDER AN AXIAL LOAD AND ELECTRIC EXCITATION: NONLINEAR PHENOMENA AND DYNAMICAL INTEGRITY. <i>International Journal of Bifurcation and Chaos in Applied Sciences and Engineering</i> , 2013, 23, 1350026.	0.7	44
28	Dynamics of Transition Regime in Bistable Vibration Energy Harvesters. <i>Journal of Vibration and Acoustics, Transactions of the ASME</i> , 2017, 139, .	1.0	44
29	Highly Tunable Electrothermally and Electrostatically Actuated Resonators. <i>Journal of Microelectromechanical Systems</i> , 2016, 25, 440-449.	1.7	43
30	One-to-One and Three-to-One Internal Resonances in MEMS Shallow Arches. <i>Journal of Computational and Nonlinear Dynamics</i> , 2017, 12, .	0.7	43
31	Simulation of Squeeze-Film Damping of Microplates Actuated by Large Electrostatic Load. <i>Journal of Computational and Nonlinear Dynamics</i> , 2007, 2, 232-241.	0.7	42
32	Multiple internal resonances in MEMS arch resonators. <i>Physics Letters, Section A: General, Atomic and Solid State Physics</i> , 2018, 382, 3393-3398.	0.9	41
33	Dynamic response of slacked single-walled carbon nanotube resonators. <i>Nonlinear Dynamics</i> , 2012, 67, 1419-1436.	2.7	40
34	Two-to-one internal resonance of MEMS arch resonators. <i>International Journal of Non-Linear Mechanics</i> , 2018, 107, 64-72.	1.4	40
35	A smart microelectromechanical sensor and switch triggered by gas. <i>Applied Physics Letters</i> , 2016, 109, .	1.5	39
36	Higher order modes excitation of electrostatically actuated clamped-clamped microbeams: experimental and analytical investigation. <i>Journal of Micromechanics and Microengineering</i> , 2016, 26, 025008.	1.5	38

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37	In-Plane MEMS Shallow Arch Beam for Mechanical Memory. <i>Micromachines</i> , 2016, 7, 191.	1.4	37
38	An investigation of the static and dynamic behavior of electrically actuated rectangular microplates. <i>International Journal of Non-Linear Mechanics</i> , 2016, 85, 81-93.	1.4	36
39	Theoretical and Experimental Investigation of the Nonlinear Behavior of an Electrostatically Actuated In-Plane MEMS Arch. <i>Journal of Microelectromechanical Systems</i> , 2016, 25, 570-578.	1.7	35
40	Highly sensitive and wide-range resonant pressure sensor based on the veering phenomenon. <i>Sensors and Actuators A: Physical</i> , 2019, 300, 111652.	2.0	35
41	Tunable nanoelectromechanical resonator for logic computations. <i>Nanoscale</i> , 2017, 9, 3449-3457.	2.8	34
42	Theoretical and experimental investigations of the crossover phenomenon in micromachined arch resonator: part II—simultaneous 1:1 and 2:1 internal resonances. <i>Nonlinear Dynamics</i> , 2020, 99, 407-432.	2.7	32
43	Frequency Shifts of Micro and Nano Cantilever Beam Resonators Due to Added Masses. <i>Journal of Dynamic Systems, Measurement and Control, Transactions of the ASME</i> , 2016, 138, .	0.9	31
44	A Resonant Gas Sensor Based on Multimode Excitation of a Buckled Microbeam. <i>IEEE Sensors Journal</i> , 2020, 20, 1778-1785.	2.4	31
45	An Experimental and Theoretical Investigation of a Micromirror Under Mixed-Frequency Excitation. <i>Journal of Microelectromechanical Systems</i> , 2015, 24, 1124-1131.	1.7	30
46	Tunable Clamped-Guided Arch Resonators Using Electrostatically Induced Axial Loads. <i>Micromachines</i> , 2017, 8, 14.	1.4	30
47	Multimode MEMS Resonator for Simultaneous Sensing of Vapor Concentration and Temperature. <i>IEEE Sensors Journal</i> , 2018, 18, 10145-10153.	2.4	30
48	Mass and position determination in MEMS mass sensors: a theoretical and an experimental investigation. <i>Journal of Micromechanics and Microengineering</i> , 2016, 26, 105009.	1.5	29
49	Analytical study of the frequency shifts of micro and nano clamped-clamped beam resonators due to an added mass. <i>Meccanica</i> , 2017, 52, 333-348.	1.2	29
50	Electrothermally Tunable Arch Resonator. <i>Journal of Microelectromechanical Systems</i> , 2017, 26, 837-845.	1.7	29
51	Resonant Gas Sensor and Switch Operating in Air With Metal-Organic Frameworks Coating. <i>Journal of Microelectromechanical Systems</i> , 2018, 27, 156-163.	1.7	29
52	Multifrequency excitation of a clamped-clamped microbeam: Analytical and experimental investigation. <i>Microsystems and Nanoengineering</i> , 2016, 2, 16002.	3.4	28
53	Experimental investigation of snap-through motion of in-plane MEMS shallow arches under electrostatic excitation. <i>Journal of Micromechanics and Microengineering</i> , 2016, 26, 015012.	1.5	26
54	Resonator-based M/NEMS logic devices: Review of recent advances. <i>Sensors and Actuators A: Physical</i> , 2020, 302, 111821.	2.0	26

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55	Integrity Analysis of Electrically Actuated Resonators With Delayed Feedback Controller. Journal of Dynamic Systems, Measurement and Control, Transactions of the ASME, 2011, 133, .	0.9	25
56	Humidity Detection Using Metal Organic Framework Coated on QCM. Journal of Sensors, 2016, 2016, 1-8.	0.6	25
57	Static and Dynamic Amplification Using Strong Mechanical Coupling. Journal of Microelectromechanical Systems, 2016, 25, 916-921.	1.7	25
58	Theoretical and experimental investigations of the crossover phenomenon in micromachined arch resonator: part I—linear problem. Nonlinear Dynamics, 2020, 99, 393-405.	2.7	25
59	Multistability in an electrically actuated carbon nanotube: a dynamical integrity perspective. Nonlinear Dynamics, 2013, 74, 533-549.	2.7	24
60	Torsion based universal MEMS logic device. Sensors and Actuators A: Physical, 2015, 236, 150-158.	2.0	24
61	Multimode excitation of a metal organics frameworks coated microbeam for smart gas sensing and actuation. Sensors and Actuators A: Physical, 2018, 283, 254-262.	2.0	24
62	Theoretical Prediction of Experimental Jump and Pull-In Dynamics in a MEMS Sensor. Sensors, 2014, 14, 17089-17111.	2.1	23
63	Theoretical and Experimental Investigation of Two-to-One Internal Resonance in MEMS Arch Resonators. Journal of Computational and Nonlinear Dynamics, 2019, 14, .	0.7	23
64	A Study for the Effect of the PCB Motion on the Dynamics of MEMS Devices Under Mechanical Shock. Journal of Microelectromechanical Systems, 2009, 18, 597-609.	1.7	22
65	An experimental and theoretical investigation of electrostatically coupled cantilever microbeams. Sensors and Actuators A: Physical, 2016, 247, 368-378.	2.0	21
66	MEMS Logic Using Mixed-Frequency Excitation. Journal of Microelectromechanical Systems, 2017, 26, 1140-1146.	1.7	21
67	Dynamics of a clamped-clamped microbeam resonator considering fabrication imperfections. Microsystem Technologies, 2015, 21, 2425-2434.	1.2	20
68	Electrothermal Frequency Modulated Resonator for Mechanical Memory. Journal of Microelectromechanical Systems, 2016, 25, 877-883.	1.7	20
69	Wideband MEMS resonator using multifrequency excitation. Sensors and Actuators A: Physical, 2016, 242, 140-145.	2.0	20
70	Highly Tunable Narrow Bandpass MEMS Filter. IEEE Transactions on Electron Devices, 2017, 64, 3392-3398.	1.6	20
71	A Compact Adder and Reprogrammable Logic Gate Using Micro-Electromechanical Resonators With Partial Electrodes. IEEE Transactions on Circuits and Systems II: Express Briefs, 2019, 66, 2057-2061.	2.2	19
72	On the response of MEMS resonators under generic electrostatic loadings: experiments and applications. Nonlinear Dynamics, 2019, 95, 2263-2274.	2.7	19

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73	Analytical expressions for the electrostatically actuated curled beam problem. <i>Microsystem Technologies</i> , 2015, 21, 1709-1717.	1.2	18
74	Natural frequencies and mode shapes of statically deformed inclined risers. <i>International Journal of Non-Linear Mechanics</i> , 2017, 94, 12-19.	1.4	18
75	A single MEMS resonator for reconfigurable multifunctional logic gates. <i>Journal of Micromechanics and Microengineering</i> , 2018, 28, 095002.	1.5	18
76	Two-to-one internal resonance in the higher-order modes of a MEMS beam: Experimental investigation and theoretical analysis via local stability theory. <i>International Journal of Non-Linear Mechanics</i> , 2021, 129, 103664.	1.4	18
77	Nonlinear Dynamics of Carbon Nanotubes Under Large Electrostatic Force. <i>Journal of Computational and Nonlinear Dynamics</i> , 2016, 11, .	0.7	17
78	Theoretical and experimental investigation of mode localization in electrostatically and mechanically coupled microbeam resonators. <i>International Journal of Non-Linear Mechanics</i> , 2020, 125, 103516.	1.4	17
79	Analytical Study of the Snap-Through and Bistability of Beams With Arbitrarily Initial Shape. <i>Journal of Mechanisms and Robotics</i> , 2020, 12, .	1.5	17
80	A Coupled Resonator for Highly Tunable and Amplified Mixer/Filter. <i>IEEE Transactions on Electron Devices</i> , 2017, 64, 2659-2664.	1.6	16
81	RF MEMS electrostatically actuated tunable capacitors and their applications: a review. <i>Journal of Micromechanics and Microengineering</i> , 2022, 32, 013002.	1.5	16
82	The Effect of Squeeze-Film Damping on the Shock Response of Clamped-Clamped Microbeams. <i>Journal of Dynamic Systems, Measurement and Control, Transactions of the ASME</i> , 2012, 134, .	0.9	15
83	Multi-mode excitation of a clamped-clamped microbeam resonator. <i>Nonlinear Dynamics</i> , 2015, 80, 1531-1541.	2.7	15
84	Toward cascable MEMS logic device based on mode localization. <i>Sensors and Actuators A: Physical</i> , 2020, 315, 112367.	2.0	14
85	A monolithic tunable symmetric bistable mechanism. <i>Smart Materials and Structures</i> , 2020, 29, 075033.	1.8	14
86	Multi-Threshold Inertial Switch for Quantitative Acceleration Measurements. <i>IEEE Sensors Journal</i> , 2021, 21, 23849-23859.	2.4	14
87	Simple Fall Criteria for MEMS Sensors: Data Analysis and Sensor Concept. <i>Sensors</i> , 2014, 14, 12149-12173.	2.1	13
88	Experimental and analytical study of highly tunable electrostatically actuated resonant beams. <i>Journal of Micromechanics and Microengineering</i> , 2015, 25, 125015.	1.5	13
89	A Microbeam Resonator With Partial Electrodes for Logic and Memory Elements. <i>IEEE Journal on Exploratory Solid-State Computational Devices and Circuits</i> , 2017, 3, 83-92.	1.1	13
90	Electrothermally actuated tunable clamped-guided resonant microbeams. <i>Mechanical Systems and Signal Processing</i> , 2018, 98, 1069-1076.	4.4	13

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91	Dynamics of V-Shaped Electrothermal MEMS-Based Resonators. Journal of Microelectromechanical Systems, 2020, 29, 1372-1381.	1.7	13
92	Experimental and theoretical investigation of the 2:1 internal resonance in the higher-order modes of a MEMS microbeam at elevated excitations. Journal of Sound and Vibration, 2021, 499, 115983.	2.1	13
93	Modeling of Beam Electrothermal Actuators. Journal of Microelectromechanical Systems, 2020, 29, 1570-1581.	1.7	12
94	Selective multiple analyte detection using multi-mode excitation of a MEMS resonator. Scientific Reports, 2022, 12, 5297.	1.6	12
95	Axially modulated arch resonator for logic and memory applications. Mechatronics, 2018, 56, 254-260.	2.0	11
96	Multifrequency excitation of an inclined marine riser under internal resonances. Nonlinear Dynamics, 2020, 99, 149-171.	2.7	11
97	Internal resonance in the higher-order modes of a MEMS beam: experiments and global analysis. Nonlinear Dynamics, 2021, 103, 2197-2226.	2.7	11
98	Resonator-Based Bidirectional Lorentz Force Magnetic Sensor. IEEE Electron Device Letters, 2021, 42, 406-409.	2.2	11
99	Static and dynamic actuations of clamped-clamped V-shaped micro-resonators under electrostatic forces. Mechanical Systems and Signal Processing, 2021, 155, 107571.	4.4	11
100	Parameter identification of an electrically actuated imperfect microbeam. International Journal of Non-Linear Mechanics, 2013, 57, 208-219.	1.4	10
101	Highly Tunable Electrostatic Nanomechanical Resonators. IEEE Nanotechnology Magazine, 2018, 17, 113-121.	1.1	10
102	A Low Power Micro-Electromechanical Resonator-Based Digital to Analog Converter. Journal of Microelectromechanical Systems, 2020, 29, 320-328.	1.7	10
103	Investigation of the response of microstructures under the combined effect of mechanical shock and electrostatic forces. Journal of Micromechanics and Microengineering, 2006, 16, 2463-2474.	1.5	10
104	A 2:1 MUX Based on Multiple MEMS Resonators. Procedia Engineering, 2016, 168, 1642-1645.	1.2	9
105	An analytic solution of the static problem of inclined risers conveying fluid. Meccanica, 2017, 52, 1175-1187.	1.2	9
106	A parity checker circuit based on microelectromechanical resonator logic elements. Physics Letters, Section A: General, Atomic and Solid State Physics, 2017, 381, 843-848.	0.9	9
107	Dynamics of Microbeams under Multi-Frequency Excitations. Micromachines, 2017, 8, 32.	1.4	9
108	Three-to-one internal resonance of inclined marine riser. International Journal of Non-Linear Mechanics, 2019, 109, 107-117.	1.4	9

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109	Design, modeling, and testing of a bidirectional multi-threshold MEMS inertial switch. <i>Sensors and Actuators A: Physical</i> , 2022, 334, 113219.	2.0	9
110	Delayed feedback controller for microelectromechanical systems resonators undergoing large motion. <i>JVC/Journal of Vibration and Control</i> , 2015, 21, 2604-2615.	1.5	8
111	Microelectromechanical resonator based digital logic elements. , 2016, , .		8
112	Mixed frequency excitation of an electrostatically actuated resonator. <i>Microsystem Technologies</i> , 2016, 22, 1967-1974.	1.2	8
113	Adjustable static and dynamic actuation of clamped-guided beams using electrothermal axial loads. <i>Sensors and Actuators A: Physical</i> , 2018, 273, 19-29.	2.0	8
114	Highly Sensitive Resonant Magnetic Sensor Based on the Veering Phenomenon. <i>IEEE Sensors Journal</i> , 2021, 21, 13165-13175.	2.4	8
115	Crossover/Veering in V-Shaped MEMS Resonators. <i>Journal of Microelectromechanical Systems</i> , 2022, 31, 74-86.	1.7	8
116	Global investigation of the nonlinear dynamics of carbon nanotubes. <i>Acta Mechanica</i> , 2017, 228, 1029-1043.	1.1	7
117	A MEMS coupled resonator for frequency filtering in air. <i>Mechatronics</i> , 2018, 56, 261-267.	2.0	7
118	Two-to-one internal resonance of an inclined marine riser under harmonic excitations. <i>Nonlinear Dynamics</i> , 2019, 95, 1301-1321.	2.7	7
119	On the double resonance activation of electrostatically actuated microbeam based resonators. <i>International Journal of Non-Linear Mechanics</i> , 2020, 121, 103437.	1.4	7
120	Investigating Mode Localization at Lower- and Higher-Order Modes in Mechanically Coupled MEMS Resonators. <i>Journal of Computational and Nonlinear Dynamics</i> , 2020, 15, .	0.7	7
121	Recent advances on MEMS based Infrared Thermopile detectors. <i>Microsystem Technologies</i> , 2022, 28, 1751-1764.	1.2	7
122	Multi-Threshold Inertial Switch With Acceleration Direction Detection Capability. <i>IEEE Transactions on Industrial Electronics</i> , 2023, 70, 4226-4235.	5.2	7
123	Investigation of the dynamics of a clamped-clamped microbeam near symmetric higher order modes using partial electrodes. <i>International Journal of Dynamics and Control</i> , 2015, 3, 173-182.	1.5	6
124	An investigation into the mechanical behavior of multi- input and multi-output MEMS resonators. <i>Sensors and Actuators A: Physical</i> , 2018, 280, 309-318.	2.0	6
125	On the response of MEMS resonators under generic electrostatic loadings: theoretical analysis. <i>Nonlinear Dynamics</i> , 2019, 97, 967-977.	2.7	6
126	A Nanoelectromechanical Resonator-Based Flash Style Analog to Digital Converter. , 2020, , .		6

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127	A Wideband Magnetic Frequency Upâ€Converter Energy Harvester. <i>Advanced Engineering Materials</i> , 2021, 23, 2001364.	1.6	6
128	Static and Dynamic Analysis of Electrostatically Actuated MEMS Shallow Arches for Various Air-Gap Configurations. <i>Micromachines</i> , 2021, 12, 930.	1.4	6
129	A state space approach for the eigenvalue problem of marine risers. <i>Meccanica</i> , 2018, 53, 747-757.	1.2	5
130	Design and Demonstration of A Compact Full Adder Using Micro-beam Resonators. , 2018, , .		5
131	On the Application of the Multiple Scales Method on Electrostatically Actuated Resonators. <i>Journal of Computational and Nonlinear Dynamics</i> , 2019, 14, .	0.7	5
132	Miniature pressure sensor based on suspended MWCNT. <i>Sensors and Actuators A: Physical</i> , 2019, 292, 11-16.	2.0	5
133	Highly sensitive low field Lorentz-force MEMS magnetometer. <i>Scientific Reports</i> , 2021, 11, 21634.	1.6	5
134	Simultaneous gas and magnetic sensing using a single heated micro-resonator. <i>Sensors and Actuators A: Physical</i> , 2022, 344, 113688.	2.0	5
135	Multi-function and cascable MEMS logic device. , 2017, , .		4
136	Fabrication and Characterization of MWCNT-Based Bridge Devices. <i>IEEE Nanotechnology Magazine</i> , 2017, 16, 1037-1046.	1.1	4
137	Task feasibility of V shape electrothermal actuators. <i>Engineering Research Express</i> , 2020, 2, 035035.	0.8	4
138	Nonlinear mode saturation in a U-shaped micro-resonator. <i>Scientific Reports</i> , 2022, 12, .	1.6	4
139	Control of Bouncing in MEMS Switches Using Double Electrodes. <i>Mathematical Problems in Engineering</i> , 2016, 2016, 1-10.	0.6	3
140	Experimental Investigation of 2:1 and 3:1 Internal Resonances in Nonlinear MEMS Arch Resonators. , 2016, , .		3
141	Natural Frequencies and Mode Shapes of Statically Deformed Inclined Risers. , 2016, , .		3
142	Approaches for Reduced-Order Modeling of Electrically Actuated von-Karman Microplates. <i>Journal of Computational and Nonlinear Dynamics</i> , 2017, 12, .	0.7	3
143	Interpreting and Predicting Experimental Responses of Micro- and Nano-Devices via Dynamical Integrity. <i>CISM International Centre for Mechanical Sciences, Courses and Lectures</i> , 2019, , 113-166.	0.3	3
144	Dynamics Characterization of a U-Shaped Micro-Resonator Portal Frame. <i>Journal of Microelectromechanical Systems</i> , 2020, 29, 1362-1371.	1.7	3

#	ARTICLE	IF	CITATIONS
145	A symmetrical bistable mechanism from combination of pre-shaped microbeams. Sensors and Actuators A: Physical, 2020, 306, 111961.	2.0	3
146	Nonparametric identification of a micro-electromechanical resonator. Mechanical Systems and Signal Processing, 2021, 161, 107932.	4.4	3
147	The static and dynamic behavior of MEMS arches under electrostatic actuation. , 2009, , .		2
148	Controlling dynamic pull-in escape in electrostatic MEMS. , 2009, , .		2
149	Jump and pull-in dynamics of an electrically actuated bistable MEMS device. MATEC Web of Conferences, 2014, 16, 04001.	0.1	2
150	Dynamics of an Imperfect Microbeam Considering its Exact Shape. , 2014, , .		2
151	Axially Modulated Clamped-Guided Arch Resonator for Memory and Logic Applications. , 2017, , .		2
152	Electrothermally Actuated Microbeams With Varying Stiffness. , 2017, , .		2
153	Nanoelectromechanical resonator for logic operations. , 2017, , .		2
154	A Sensitive Resonant Gas Sensor Based on Multimode Excitation of a Buckled Beam. , 2019, , .		2
155	Efficient Activation of Nanomechanical Resonators. Advanced Electronic Materials, 2019, 5, 1800356.	2.6	2
156	Spring-Shaped Inductor Tuned With a Microelectromechanical Electrothermal Actuator. IEEE Magnetics Letters, 2020, 11, 1-5.	0.6	2
157	Statics and Dynamics of V-Shaped Microbeams Under Axial Forces. Journal of Computational and Nonlinear Dynamics, 2021, 16, .	0.7	2
158	Analytical and experimental study of the dynamics of a micro-electromechanical resonator based digital-to-analog converter. Journal of Micromechanics and Microengineering, 2021, 31, 125010.	1.5	2
159	Modeling the effects of the PCB motion on the response of microstructures under mechanical shock. , 2010, , .		1
160	Nonlinear Dynamic Response of an Electrically Actuated Imperfect Microbeam Resonator. , 2013, , .		1
161	Investigation of a Delayed Feedback Controller of MEMS Resonators. , 2013, , .		1
162	An Efficient Reduced-Order Model for the Nonlinear Dynamics of Carbon Nanotubes. , 2014, , .		1

#	ARTICLE	IF	CITATIONS
163	Static Response of Microbeams due to Capillary and Electrostatic Forces. , 2015, , .		1
164	Nonlinear Phenomena in the Single-Mode Dynamics in an AFM Cantilever Beam. , 2016, , .		1
165	The Effect of an Added Mass on the Frequency Shifts of a Clamped-Clamped Microbeam for Bio-Mass Detection. , 2016, , .		1
166	Nonlinear-Based MEMS Sensors and Active Switches for Gas and Acceleration Applications. Proceedings (mdpi), 2016, 1, .	0.2	1
167	In-Plane Air Damping of NEMS and MEMS Resonators. , 2018, , .		1
168	Mechanical Computing Using Multifrequency Excited NEMS Resonator. , 2018, , .		1
169	Nonparametric Identification of a Nonlinear MEMS Resonator. , 2022, , 405-415.		1
170	Nonlinear Dynamics of an Electrically Actuated MEMS Device: Experimental and Theoretical Investigation. , 2013, , .		0
171	Electrostatically actuated resonant switches for earthquake detection. , 2013, , .		0
172	Investigation of the Dynamics of a Clamped-Clamped Microbeam Near the Third Mode Using a Partial Electrode. , 2014, , .		0
173	Simple and Accurate Analytical Solutions of the Electrostatically Actuated Curled Beam Problem. , 2014, , .		0
174	Multifrequency Excitation of a Clamped-Clamped Microbeam. , 2015, , .		0
175	The Dynamics of a Doubly Clamped Microbeam Near the Primary Resonance: Experimental and Analytical Investigation. , 2015, , .		0
176	An Experimental Investigation of the Dynamic Behavior of an In-Plane MEMS Shallow Arch Under Electrostatic Excitation. , 2015, , .		0
177	Investigation of the nonlinear static and dynamic behaviour of rectangular microplates under electrostatic actuation. MATEC Web of Conferences, 2016, 83, 04005.	0.1	0
178	Electrothermally Tunable Bridge Resonator. , 2016, , .		0
179	Static and Dynamic Amplification Using Strong Mechanical Coupling. , 2016, , .		0
180	Mass and Position Determination in MEMS Resonant Mass Sensors: Theoretical and Experimental Investigation. , 2016, , .		0

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181	Initially Imperfect MEMS Microplates Under Electrostatic Actuation: Theory and Experiment. , 2016, , .		0
182	Nonlinear-Based Switch Triggered by Gas Using Electrostatically Actuated Microbeams. , 2016, , .		0
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